

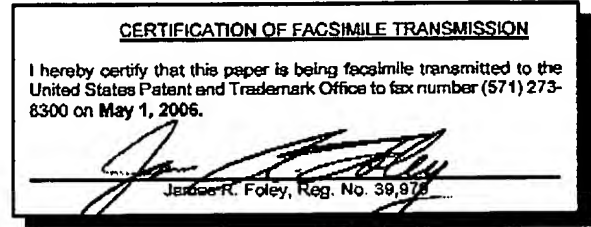
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MAY 01 2006

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Serial No.: 10/800,219)
)
Filed: March 12, 2004)
)
Title: METHOD FOR VERIFYING RET)
LATENT IMAGE SENSITIVITY)
TO MASK MANUFACTURING)
ERRORS)
)
Inventors: Nadya G. Strelkova et al.)
)
Art Unit: 2825)
)
Examiner: Nelson C. Lam)
)
Atty. Ref: 02-2396)



RESPONSE TO THE OFFICE ACTION MAILED DECEMBER 1, 2005

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In the matter of the above-identified application and in response to the Office Action mailed December 1, 2005, kindly enter the following amendments and consider the following remarks toward reconsideration of the present application. A Petition for Extension of Time is enclosed, extending the deadline for responding to the Office Action to May 1, 2006. Therefore, this Response is considered timely.

Amendments to the Title:

Please change the title to the following:

"Method and Apparatus for Verifying the Post-Optical Proximity Corrected Mask Wafer Image
Sensitivity to Reticle Manufacturing Errors".

Serial No. 10/800,219
Art Unit: 2825
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